

DECLARATION OF JOINT INVENTORS FOR PATENT APPLICATION

As the below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am the original, first and joint inventor of the subject matter which is claimed and for which a patent is sought on the invention entitled: **Chemical Vapor Deposition Apparatuses and Deposition Methods, the specification of which is attached hereto.**

I hereby state that I have reviewed and understand the contents of the above-identified specification, including the claims.

I acknowledge the duty to disclose information known to me to be material to patentability as defined in Title 37, Code of Federal Regulations §1.56.

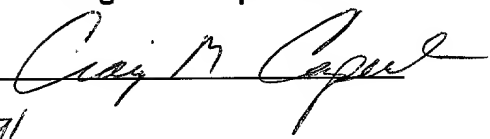
PRIOR FOREIGN APPLICATIONS:

I hereby state that no applications for foreign patents or inventor's certificates have been filed prior to the date of execution of this declaration.

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statement may jeopardize the validity of the application or any patent issued therefrom.

EL 465855490

Full name of inventor: Craig M. Carpenter


Inventor's Signature: Date: 1 March 2001

Residence: Boise, Idaho 82716

Citizenship: U.S.A

Post Office Address: 4186 E. Carnation Court

Full name of inventor: Ross S. Dando

Inventor's Signature: Date: 1, March 2001

Residence: Nampa, Idaho 83686-7932

Citizenship: U.S.A

Post Office Address: 3113 Teepee Court

MICRON\DE-02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. Filed Herewith
 Filing Date Filed Herewith
 Inventor Craig M. Carpenter, et al
 Assignee Micron Technology, Inc.
 Group Art Unit Unknown
 Examiner Unknown
 Attorney's Docket No. MI22-1563
 Title: Chemical Vapor Deposition Apparatuses and Deposition Methods

POWER OF ATTORNEY BY ASSIGNEE AND CERTIFICATE BY ASSIGNEE UNDER 37 CFR §3.73(b)

To: Assistant Commissioner for Patents
 Washington, D.C. 20231

Sir:

MICRON TECHNOLOGY, INC., the Assignee of the entire right, title and interest in the above-identified patent application by assignment attached hereto, hereby appoints the attorneys and agents of the firm of **WELLS, ST. JOHN, ROBERTS, GREGORY & MATKIN P.S.**, listed as follows:

David P. Roberts	Reg. No. 23,032
Randy A. Gregory	Reg. No. 30,386
Mark S. Matkin	Reg. No. 32,268
James L. Price	Reg. No. 27,376
Deepak Malhotra	Reg. No. 33,560
Mark W. Hendricksen	Reg. No. 32,356
David G. Latwesen	Reg. No. 38,533
George G. Grigel	Reg. No. 31,166
Keith D. Grzelak	Reg. No. 37,144
James D. Shaurette	Reg. No. 39,833
Frederick M. Fliegel	Reg. No. 36,138
Donald Brent Kenady	Reg. No. 40,045
James E. Lake	Reg. No. 44,854
Bernard Berman	Reg. No. 37,279

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and also attorneys Michael L. Lynch (Reg. No. 30,871) and Lia Pappas Dennison (Reg. No. 34,095) of Micron Technology, Inc., as its attorneys with full power of substitution to prosecute this application and transact all business in the Patent and Trademark Office connected therewith.

The Assignee certifies that the above-identified Assignment has been reviewed and to the best of Assignee's knowledge and belief, title is in the Assignee, and a copy of the Assignment is submitted herewith.

Please direct all correspondence regarding this application to:

Customer No. 021567
Wells, St. John, Roberts, Gregory & Matkin P.S.
Attn: James E. Lake
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

Telephone: (509) 624-4276
Facsimile: (509) 838-3424

MICRON TECHNOLOGY, INC.

Dated: 2-8-01

By: 

Name: Michael L. Lynch, Esq.
Title: Chief Patent Counsel

Attachment: Copy of Assignment; Copy of Board of Directors' Resolution